

## IN THE CLAIMS:

1. **(Currently Amended)** A method for forming a pattern in a polymeric composition film carried on a substrate, said method comprising:

obtaining a mold of a material, which mold is hard relative to the polymeric composition film,

~~the film comprising a polymeric composition blended with a release agent to include an internal mold release agent and capable of being deformed by said mold at a temperature of less than 200°C;~~

the mold having first and second protruding features spaced apart from each other and a recess formed thereby, the first and second features and the recess having a shape forming a mold pattern and providing at least one mold pattern lateral dimension which is less than 200 nm;

urging the mold into the polymeric composition film under a molding pressure;

the thickness of the polymeric composition film under the protruding features of the mold being reduced to form areas of reduced thickness, thereby forming the mold pattern in the polymeric composition film;

curing the polymeric composition film by photocuring, thermally curing, or both thermally curing and photocuring ~~the polymeric composition~~ for increased mechanical strength;

removing the mold from the cured polymeric composition film; and

removing from the cured polymeric composition film the areas of reduced thickness, thereby forming exposed portions of the surface of the substrate which underlie the areas of reduced thickness such that the exposed portions of the surface of

the substrate substantially replicate the mold pattern and have at least one lateral dimension which is less than 200 nm nm;

~~wherein the polymeric composition comprises a thermosettable polymeric composition and a photocurable polymeric composition.~~

**2. (Previously Presented)** The method of claim 1, wherein the polymeric composition comprises a block copolymer, a grafted polymer, a telechelic polymer, a star polymer, a dendrimer, or any combination thereof.

**3. (Previously Presented)** The method of claim 1, wherein the polymeric composition comprises: poly(methyl methacrylate), poly(bisphenol-A carbonate), poly(methylhexadecylsiloxane), poly(methylacrylate), poly(n-butyl acrylate), poly(octadecyl methacrylate), poly(isobutyl methacrylate), poly(butyl methacrylate), poly(vinylacetate), poly(vinyl stearate), poly(ethylene oxide), polycaprolactone, poly( $\alpha$ -methylstyrene), poly(vinyl stearate)/poly(methyl methacrylate), poly(methylhexadecylsiloxane)/poly(methyl methacrylate), poly(octadecyl methacrylate)/poly(methyl methacrylate), poly(butyl methacrylate-co-isobutylmethacrylate), poly(butyl methacrylate-co-methyl methacrylate), poly(dimethylsiloxane-co- $\alpha$ -methylstyrene), poly(ethylene-co-vinylacetate)-graft(t-maleic anhydride), poly(vinyl chloride-co-vinylacetate), poly(vinyl chloride-co-isobutylvinylether), poly(chlorotrifluoroethylene-co-vinylidene fluoride), or any combination thereof.

**4. (Original)** The method of claim 1, wherein the polymeric composition comprises an oligomer, said oligomer comprising an epoxy resin, an acrylic (methacrylic) oligomer, a reactive polysiloxane oligomer, or any combination thereof.

5. **(Original)** The method of claim 1, wherein the polymeric composition further comprises a monomer, said monomer comprising a C<sub>8</sub>-C<sub>20</sub> alkyl methacrylate, a fluorinated alkyl (meth)acrylate monomer, or any combination thereof.

6. **(Previously Presented)** The method of claim 1, wherein the polymeric composition further comprises a crosslinker, said crosslinker comprising divinyl benzene, trimethylolpropane triacrylate, or any combination thereof.

7. **(Canceled).**

8. **(Previously Presented)** The method of claim 1, wherein said polymeric composition is capable of being deformed at a temperature of less than about 100°C.

9. **(Canceled).**

10. **(Currently Amended)** The method of claim ~~[[1]]~~ 70, wherein said photocurable polymeric composition is capable of curing in less than about 2 seconds on exposure to radiation.

11. **(Currently Amended)** The method of claim ~~[[1]]~~ 70, wherein said photocurable polymeric composition has a viscosity of greater than about 2 poise at 25°C.

12. **(Original)** The method of claim 11, wherein said photocurable polymeric composition has a viscosity in the range of about 10 poise to about 30 poise.

13. **(Currently Amended)** The method of claim ~~[[1]]~~ 70, wherein said photocurable polymeric composition comprises an oligomer, said oligomer comprising silicon atoms.

**14. (Currently Amended)** The method of claim ~~[[1]]~~ 70, wherein said photocurable polymeric composition is capable of crosslinking in less than about 2 seconds on exposure to radiation.

**15. (Currently Amended)** The method of claim ~~[[1]]~~ 70, wherein said photocurable polymeric composition comprises up to about 90 weight percent monomer.

**16. (Currently Amended)** The method of claim 1, wherein said polymeric composition film further ~~comprises~~ includes at least one of a plasticizer, a monomer, a crosslinker, a lubricant, an additive, or any combination thereof.

**17. (Currently Amended)** The method of claim 1, wherein said polymeric composition film ~~comprises said polymeric composition, up to about 80 weight percent of~~ includes a plasticizer, and ~~up to about 30 weight percent of~~ a mold release agent.

**18. (Canceled).**

**19. (Previously Presented)** The method of claim 1, wherein sub-50 nanometer structures are formed.

**20 – 29. (Canceled).**

**30. (Currently Amended)** ~~The~~ ~~[[A]]~~ method of Claim 1 wherein ~~for forming a plurality of structures having at least one dimension less than 200 nm, said method comprising:~~

~~obtaining a mold of a material, which mold is hard relative to~~ said polymeric composition film is a nanoimprint resist ~~resist,~~

~~the nanoimprint resist comprising a polymeric composition blended with a release agent to include an internal mold release agent and capable of being deformed by said~~

~~mold at a temperature of less than 200°C., wherein the polymeric composition comprises a thermosettable polymeric composition and a photocurable polymeric composition;~~

~~the mold having first and second protruding features spaced apart from each other and a recess formed thereby, the first and second features and the recess having a shape forming a mold pattern and providing at least one mold pattern lateral dimension which is less than 200 nm;~~

~~urging the mold into the nanoimprint resist under a molding pressure;~~

~~the thickness of the nanoimprint resist under the protruding features of the mold being reduced to form areas of reduced thickness, thereby forming the mold pattern in the nanoimprint resist, the mold pattern comprising a plurality of structures having at least one dimension less than 200 nm;~~

~~photocuring, thermally curing, or both thermally curing and photocuring the polymeric composition;~~

~~removing the mold from the nanoimprint resist, the polymeric composition retaining said plurality of structures; and~~

~~removing from the nanoimprint resist the areas of reduced thickness, thereby forming exposed portions of the surface of the substrate which underlie the areas of reduced thickness such that the exposed portions of the surface of the substrate substantially replicate the mold pattern and have at least one lateral dimension which is less than 200 nm.~~

**31 – 34. (Cancelled).**

**35. (Currently Amended)** The method of claim [[30]] 1 wherein the step of curing comprises includes ultraviolet exposure of said polymeric composition film.

**36. (Currently Amended)** The method of claim [[30]] 1 wherein the step of curing comprises includes a thermal treatment of said polymeric composition film.

**37. (Currently Amended)** The method of claim [[30]] 1 wherein the step of curing comprises includes both ultraviolet exposure and thermal treatment of said polymeric composition film.

**38. (Currently Amended)** A method for forming a pattern in a polymeric composition film carried on a substrate, said method comprising:

obtaining a mold of a material, which mold is hard relative to the polymeric composition film,

the polymeric composition film ~~comprising a polymeric composition blended with a release agent to include an internal mold release agent and a~~ including a crosslinker and capable of being deformed by said mold at a temperature of less than 200°C., the ~~polymeric composition~~ and comprising a thermosettable polymeric composition and a photocurable composition;

the mold having first and second protruding features spaced apart from each other and a recess formed thereby, the first and second features and the recess having a shape forming a mold pattern and providing at least one mold pattern lateral dimension which is less than 200 nm;

urging the mold into the polymeric composition film under a molding pressure;

the thickness of the polymeric composition film under the protruding features of the mold being reduced to form areas of reduced thickness, thereby forming the mold pattern in the polymeric composition film;

crosslinking the polymeric composition film;

removing the mold from the crosslinked polymeric composition film; and

removing from the crosslinked polymeric composition film the areas of reduced thickness, thereby forming exposed portions of the surface of the substrate which underlie the areas of reduced thickness such that the exposed portions of the surface of the substrate substantially replicate the mold pattern and have at least one lateral dimension which is less than 200 nm.

**39. (Previously Presented)** The method of claim 38, wherein the polymeric composition comprises: poly(methyl methacrylate), poly(bisphenol-A carbonate), poly(methylhexadecylsiloxane), poly(methylacrylate), poly(n-butyl acrylate), poly(octadecyl methacrylate), poly(isobutyl methacrylate), poly(butyl methacrylate), poly(vinylacetate), poly(vinyl stearate), poly(ethylene oxide), polycaprolactone, poly( $\alpha$ -methylstyrene), poly(vinyl stearate)/poly(methyl methacrylate), poly(methylhexadecylsiloxane)/poly(methyl methacrylate), poly(octadecyl methacrylate)/poly(methyl methacrylate), poly(butyl methacrylate-co-isobutylmethacrylate), poly(butyl methacrylate-co-methyl methacrylate), poly(dimethylsiloxane-co- $\alpha$ -methylstyrene), poly(ethylene-co-vinylacetate)-graft(t-maleic anhydride), poly(vinyl chloride-co-vinylacetate), poly(vinyl chloride-co-isobutylvinylether), poly(chlorotrifluoroethylene-co-vinylidene fluoride), or any combination thereof.

**40. (Previously Presented)** The method of claim 38, wherein the polymeric composition comprises an oligomer, said oligomer comprising an epoxy resin, an acrylic (meth)acrylic oligomer, a reactive polysiloxane oligomer, or any combination thereof.

**41. (Previously Presented)** The method of claim 38, wherein the polymeric composition further comprises a monomer, said monomer comprising a C<sub>8</sub>-C<sub>20</sub> alkyl methacrylate, a fluorinated alkyl (meth)acrylate monomer, or any combination thereof.

**42. (Previously Presented)** The method of claim 38, wherein crosslinker is divinyl benzene, trimethylolpropane triacrylate, or any combination thereof.

**43. (Currently Amended)** The method of claim 1, in which the polymeric composition film comprises a ~~single or multiple layers of composites~~ at least one composite layer.

**44. (Currently Amended)** The method of claim 1, wherein the polymeric composition film comprises a plurality of layers and ~~in which~~ the mold imprints at least one layer of ~~multiple~~ said plurality of layers of a composite.

**45. (Cancelled)**

**46. (Currently Amended)** The method of claim ~~[[30]]~~ 38, in which the polymeric composition film comprises a ~~single or multiple layers of composites~~ at least one composite layer.

**47. (Currently Amended)** The method of claim ~~[[30]]~~ 38, wherein the polymeric composition film comprises a plurality of layers and ~~in which~~ the mold imprints at least one layer of ~~multiple~~ said plurality of layers of a composite.

**48. (Canceled).**



**49. (Currently Amended)** A method for forming a pattern in a film carried on a substrate, said method comprising:

obtaining a mold of a material, which mold is hard relative to the film,

the film comprising a thermoplastic ~~polymer~~, polymer and a photocurable polymer ~~and an internal mold release agent~~, and which is capable of being deformed by said mold at a temperature of less than 200°C.;

the mold having first and second protruding features spaced apart from each other and a recess formed thereby, the first and second features and the recess having a shape forming a mold pattern and providing at least one mold pattern lateral dimension which is less than 200 nm;

urging the mold into the film under a molding pressure;

the thickness of the film under the protruding features of the mold being reduced to form areas of reduced thickness, thereby forming the mold pattern in the film;

removing the mold from the film; and

removing from the film the areas of reduced thickness, thereby forming exposed portions of the surface of the substrate which underlie the areas of reduced thickness such that the exposed portions of the surface of the substrate substantially replicate the mold pattern and have at least one lateral dimension which is less than 200 nm.

**50. – 54. (Cancelled)**

**55. (Previously Presented)** The method of claim 49, wherein the thermoplastic polymer comprises poly(vinylacetate).

**56. (Previously Presented)** The method of claim 49, wherein the thermoplastic polymer comprises poly(butyl methacrylate).

**57. (Previously Presented)** The method of claim 49, wherein the thermoplastic polymer comprises poly(methylhexadecylsiloxane).

**58. (Previously Presented)** The method of claim 49, wherein the thermoplastic polymer comprises polystyrene.

**59. (Previously Presented)** The method of claim 49, wherein the thermoplastic polymer comprises poly(octadecyl methacrylate).

**60. (Previously Presented)** The method of claim 49, wherein the thermoplastic polymer comprises poly(vinylchloride-co-vinylacetate).

**61. (Cancelled)**

**62. (Cancelled)**

**63. (Cancelled)**

**64. (Previously Presented)** The method of claim 38 wherein after imprinting the film, the film is further treated by post-imprint thermal baking for improving mechanical strength.

**65. (Previously Presented)** The method of claim 38 wherein after imprinting the film, the film is further treated by post-imprint UV exposure for improving mechanical strength.

**66. (Previously Presented)** The method of claim 38 wherein after imprinting the film, the film is further treated by post-imprint thermal baking and post-imprint UV exposure for improving mechanical strength.

**67. (Previously Presented)** The method of claim 49 wherein after imprinting the film, the film is further treated by post-imprint thermal baking for improving mechanical strength.

**68. (Previously Presented)** The method of claim 49 wherein after imprinting the film, the film is further treated by post-imprint UV exposure for improving mechanical strength.

**69. (Previously Presented)** The method of claim 49 wherein after imprinting the film, the film is further treated by post-imprint thermal baking and post-imprint UV exposure for improving mechanical strength.

**70. (New)** The method of Claim 1 wherein the polymeric composition is photocurable.

**71. (New)** The method of Claim 1 wherein the polymeric composition is thermosettable.